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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/540,600	06/24/2005	Tetsuro Takamatsu	TLO-2-PCT/Minori	4249
	7590 01/03/2007 N, OTTINGER, ISRAEL	EXAMINER		
& SCHIFFMIL	LER, P.C.		WONG, TINA MEI SENG	
489 FIFTH AV NEW YORK, N			ART UNIT	PAPER NUMBER
			2874	
SHORTENED STATUTOR	Y PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE	
3 MONTHS 01/03/2007 PAP		ER		

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

	Application No.	Applicant(s)				
	10/540,600	TAKAMATSU ET AL.				
Office Action Summary	Examiner	Art Unit				
	Tina M. Wong	2874				
- The MAILING DATE of this communication appears on the cover sheet with the correspondence address - Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailling date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tim will apply and will expire SIX (6) MONTHS from a BANDONE.	l. rely filed the mailing date of this communication.				
Status						
Responsive to communication(s) filed on 2a) ☐ This action is FINAL . 2b) ☑ This 3) ☐ Since this application is in condition for allowant closed in accordance with the practice under Expression in the practice of the condition is accordance.	action is non-final. nce except for formal matters, pro					
Disposition of Claims						
4) Claim(s) 8-14 is/are pending in the application. 4a) Of the above claim(s) is/are withdraw 5) Claim(s) is/are allowed. 6) Claim(s) 8 and 10-14 is/are rejected. 7) Claim(s) 9 is/are objected to. 8) Claim(s) are subject to restriction and/or Application Papers 9) The specification is objected to by the Examiner 10) The drawing(s) filed on 24 June 2005 is/are: a) Applicant may not request that any objection to the or	vn from consideration. r election requirement. r. ⊠ accepted or b) □ objected to leading to lead t	37 CFR 1.85(a).				
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119	ammor. Note the attached Office					
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.						
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 8/24/05.	4) Interview Summary (Paper No(s)/Mail Da 5) Notice of Informal Pa 6) Other:	e				

DETAILED ACTION

Priority

Receipt is acknowledged of papers submitted by the International Bureau under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 8 and 10-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over U.S. Patent 6,404,545 to Ishiwata.

In regards to claims 8, 10, 13 and 14, Ishiwata discloses a microscope (Figure 3) comprising a light source (17), an objective lens (2) for focusing an irradiation light beam from the light source into a sample (1), a convergence (3) and collimation (18) lens, a phase varying means (14) arranged between the convergence and collimation lenses for varying the phase of the transmitted might beam in a given area and a rotating disc (13) having a plurality of phase plate segments having different optical characteristics (Figure 4).

But Ishiwata fails to specifically disclose the pair of lenses to be placed on the same axis as when the light source enters the objective lens. However, by placing the pair of lenses on either the same axis or different axes yields the same end result. The light beams passes through both lenses to converge and collimate the light beam. Furthermore, it has been held that rearranging parts of an invention involves only routine skill in the art (*In re Japikse*, 86 USPQ)

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70), therefore, it would have been obvious at the time the invention was made to a person having ordinary skill in the art to have placed the pair of lenses on the same or different axes since by either position yields the same end result.

Additionally, Ishiwata fails to specifically disclose stepwise adjusting a depth of an observation plane of the objective lens. However, Ishiwata does disclose a three dimensional image. Furthermore, Ishiwata also discloses adjusting/moving the phase varying means in order to obtain different points of information from the specimen. Therefore, it would have been obvious at the time the invention was made to a person having ordinary skill in the art for the adjustment to be at least a stepwise adjustment in depth since (1) the image is a three dimensional illumination and (2) moving the phase varying means, either stepwise or continuously, would meet the limitation of a stepwise movement since a continuous movement is actually multiple very small stepwise movements placed together closely in time.

In regards to claims 11 and 12, Ishiwata shows the phase varying means with a film having different thicknesses (12a & 12b; slits) and therefore different refractive indices so as to affect the different optical characteristics.

Allowable Subject Matter

Claim 9 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

In regards to claim 9, the prior art fails to disclose or reasonably suggest all of the limitations of the base claim (claim 8), any intervening claims (none) and further teach a scanner arranged between the light source and a pair of lenses, the scanner to include a microlens array

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disc, a Nipkow disc and a dichroic mirror between the microlens array disc and a Nipkow disc for transmitting the light beam from the light source while reflecting light returned from the sample.

Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. None of the documents cited by the Examiner discloses or reasonably suggests the allowable subject matter discussed above.

The documents submitted by applicant in the Information Disclosure Statement have been considered and made of record. Note attached copy of form PTO-1449. None of the references submitted by Applicant discloses or reasonably suggest the allowable subject matter discussed above.

Inventorship

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

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Conclusion

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tina M. Wong whose telephone number is (571) 272-2352. The examiner can normally be reached on Monday-Friday 8:30-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Rodney Bovernick can be reached on (571) 272-2344. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Jina M Wong
Patent Examiner

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